



**ELECTRONIC COPY**

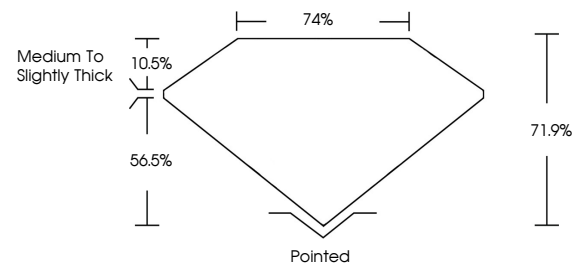
LG777626621  
Report verification at igi.org



February 25, 2026  
IGI Report Number **LG777626621**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **7.01 X 6.66 X 4.79 MM**  
**GRADING RESULTS**  
Carat Weight **2.01 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**

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**PROPORTIONS**

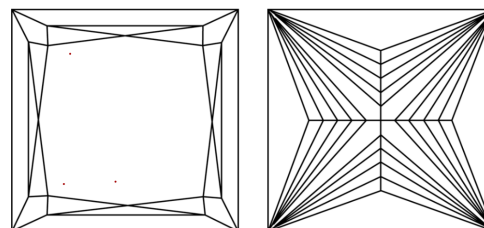


Sample Image Used

**GRADING RESULTS**

Carat Weight **2.01 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 2**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG777626621**

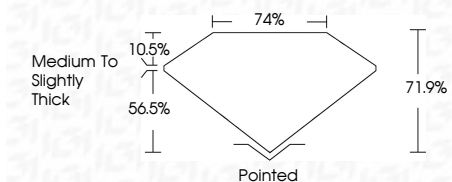
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG777626621**  
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**IGI**



February 25, 2026  
IGI Report No LG777626621  
**PRINCESS CUT**  
2.01 CARATS  
D  
7.01 X 6.66 X 4.79 MM  
Color Grade **D**  
Clarity Grade **VVS 2**  
Depth **56.5%**  
Table **10.5%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG777626621**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa